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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/233,377  
Filing Date ..... January 18, 1999  
Inventor ..... Gurtej S. Sandhu et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... T. Pham  
Attorney's Docket No. .... MI22-1114  
Title: Method of Forming a Refractory Metal Silicide (as Amended)

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Reference - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patent listed on the attached Form PTO-1449. No admission is made regarding whether the submitted reference is prior art.

Citation of this reference is respectfully requested.

Respectfully submitted,

Date: Feb. 19, 2002

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